



EXPIRED PROCEDURE - EXAMINING GROUP 2879

S/N 09/145,595

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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ji Ung Lee

Examiner: Karabi Gubara

Serial No.: 09/145,595

Group Art Unit: 2879

Filed: September 2, 1998

Docket: 303.537US1

Title: FIELD EMISSION DEVICES HAVING STRUCTURE FOR REDUCED
EMITTER TIP TO GATE SPACING

AMENDMENT & RESPONSE UNDER 37 C.F.R. § 1.116

Box AF
Commissioner for Patents
Washington, D.C. 20231

In response to the Final Office Action mailed February 26, 2002, please amend the application as follows, and consider the appended remarks rendered in **Appeal Brief format**.

Applicant has carefully reviewed and considered the Office Action mailed on February 26, 2002, and the references cited therewith.

No claims are amended or cancelled. Claims 36-60 remain pending in this application.

1. REAL PARTY IN INTEREST

The real party in interest of the above-captioned patent application is the assignee, Micron Technology, Inc., a Delaware corporation doing business at 8000 South Federal Way, P.O. Box 6, Boise, Idaho 83707-0006.

2. RELATED APPEALS AND INTERFERENCES

There are no other appeals or interferences known to the Applicant which will have a bearing on the Board's decision in the present appeal.

3. STATUS OF THE CLAIMS

Claims 36-60 are pending, and claims 36-60 are the subject of the present appeal (see Appendix 1).